

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Inventors: Stuart T. STANTON

Docket No.: 3731-0177P

Agere Case No.: 123635/Stanton 6

Title: PROJECTION ELECTRON BEAM LITHOGRAPHY APPARATUS AND  
METHOD EMPLOYING AN ESTIMATOR

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

Date: August 29, 2001

Sir:

Enclosed are the following papers relating to the above-named application for patent:

Specification 33 sheets

Formal Drawings five (5) (sheets)

The fee has been calculated as shown below:

CLAIMS AS FILED				
	NO. FILED	NO. EXTRA	RATE	CALCULATIONS
Total Claims	16 -20	0	X \$18. =	\$0
Independent Claims	2 -3	0	X \$80. =	\$0
Multiple Dependent Claim(s), if applicable			x \$270. =	0
BASIC FEE				\$710.00
TOTAL FEE				\$710.00

1c971 U.S. PTO  
09/940512  
08/29/01

08/29/01

09/04/01 09/04/01

Please file the application and charge **Agere Systems Inc. Deposit Account No. 50-1735** the amount of \$710.00, to cover the filing fee. Triplicate copies of this letter are enclosed. In the event of non-payment or improper payment of a required fee, the Commissioner is authorized to charge or to credit **Deposit Account No. 50-1735** as required to correct the error.

Please address all correspondence to:

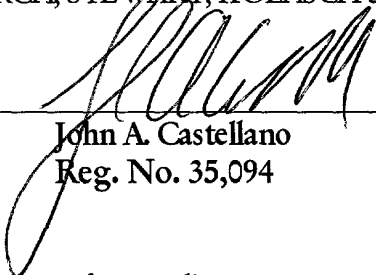
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Respectfully submitted,

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